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BIBDATASHEET

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CONFIRMATION NO. 4337

SERIAL NUMBER 10/603,924	FILING OR 371(c) DATE 06/24/2003 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. JC-7109-CIP

APPLICANTS

Shao-Chung Hu, Taipei, TAIWAN;
Teng-Chun Tsai, Hsinchu, TAIWAN;
Chia-Lin Hsu, Taipei, TAIWAN;
Yung-Tsung Wei, Tainan Hsien, TAIWAN;

** **CONTINUING DATA** ***************************

This application is a CIP of 09/854,006 05/10/2001 PAT 6,696,361
_TW_

** **FOREIGN APPLICATIONS** ******************** _None_

_TW_ TAIWAN 90109738 04/24/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
** 11/11/2003

Foreign Priority claimed ☑ yes ☐ no 35 USC 119 (a-d) conditions met ☑ yes ☐ no ☐ Met after Allowance Verified and Acknowledged _Examiner's Signature_ Initials	STATE OR COUNTRY TAIWAN	SHEETS DRAWING 4	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 2

ADDRESS
23900

TITLE
METHOD OF REMOVING CONTAMINANTS FROM A SILICON WAFER AFTER CHEMICAL-MECHANICAL POLISHING OPERATION

FILING FEE RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	☐ All Fees
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